

## Notic of References Cited

Application/Control N 09/437,135

Applicant(s)/Patent Under Reexamination YAMAZAKI ET AL.

Examiner Erik Kielin Art Unit 2813

Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,996,575	02-1991	Ipri et al.	257/369
	В	US-5,116,771	05-1992	Karulkar, Pramod C.	257/369
	С	US-5,274,279	12-1993	Misawa et al.	326/103
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q			-		
	R					
	s					
	Т					

## NON-PATENT DOCUMENTS

*	<u> </u>	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Wolf, et al. Silicon Processing for the VLSI Era, Vol. 1-Process Technology, Lattice Press: Sunset Beach CA, 1986, pp. 183-184.					
	V						
	w						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.